

JFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Shui-Ming Cheng et al.**

Examiner: **Laura M. Schillinger**

Serial No.: **10/743,985**

Group Art Unit: **2813**

Filed: **12/22/2003**

Confirmation No.: **9060**

For: BODY CONTACT FORMATION IN PARTIALLY DEPLETED SILICON ON INSULATOR DEVICE

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: February 3, 2006



Maria E. Provencio

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL OF FORMAL DRAWINGS


Sir:

Attached are 7 Replacement Sheets with formal drawings for Figs. 1A-3H to replace the informal drawings filed with the above-captioned U.S. patent application. There have been no substantive changes made to these drawings.

The Assistant Commissioner for Patents is hereby authorized to charge any fees or credit any excess payment that may be associated with this communication to deposit account 04-1679.

Respectfully submitted,

Dated: February 3, 2006



Mark J. Marcelli, Reg. No. 36,593
Attorney for Applicants

Attachment: As Noted

DUANE MORRIS LLP
101 West Broadway, Suite 900
San Diego, CA 92101
Telephone: (619) 744-2200
Facsimile: (619) 744-2201